

Docket No.: R2180.0193/P193
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Naohiro Ueda

Application No.: 10/801,838

Confirmation No.: 3147

Filed: March 17, 2004

Art Unit: 2814

For: SEMICONDUCTOR APPARATUS AND
METHOD OF MANUFACTURING THE
SAME

Examiner: A. Kalam

DO NOT ENTER: /A.K./

AMENDMENT AFTER FINAL OFFICE ACTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Madam:

INTRODUCTORY COMMENTS

In response to the Office Action dated April 15, 2009, finally rejecting claims 1-10 and 17-36, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 1 of this paper.

Remarks begin on page 6 of this paper.